IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In regard to the application of: Naor WAINER et al.

Serial No: US Divisional of 10/465,075

Group Art Unit: To be assigned

Filed

Herewith

Examiner: Unknown

For :

PIXELATED PHOTON DETECTOR

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The present application is a divisional application under 35 U.S.C. §111(a) of U.S. Application No. 10/465,075 which is a divisional application under 35 U.S.C. §111(a) of U.S. Application No. 09/806,084 which is a national application under 35 U.S.C. §371 of PCT Application No. PCT/IL98/00462.

The Examiner is respectfully requested to review and consider art, in accordance with MPEP 2001.06 and to indicate in the first office action that he has considered this art. Additionally, the Examiner is respectfully requested to cite those prior art publications mentioned in this application which the examiner considers to be material or relevant to the present claims.

Further, in order to comply with discretionary regulations 37 C.F.R. §1.97 and §1.98, attached is Form PTO-1449 listing the cited art. This art contains information which the Examiner may consider to be important in deciding whether to allow the present application to issue as a patent.

Applicants wish to point out that the items 1-7 and 12-22 were cited in parent file 09/806,084, additionally, items 8-11 were cited by the Examiner in parent file 10/464,075. Copies of these items are not attached as they are available in the parent files.

In accordance with MPEP Section 609 it is requested that each document cited (including any mentioned in Applicants' specification which is not repeated on the attached PTO-1449 form) be given thorough consideration and that it be cited of record in the

prosecution history of the present application by initialing on PTO-1449 form, so that it will appear on the face of the patent issuing on the present application, even if the Examiner does not consider it sufficiently pertinent to use in a rejection, or otherwise does not believe that the guidelines for citation have been fully complied with.

The present Information Disclosure Statement is being submitted in compliance with 37 C.F.R. §1.56 as an Examiner might consider any cited document important in deciding whether to allow the application to issue as a patent, but the citation of each document is not to be construed as an admission that such document is necessarily relevant or prior art. No representation is intended that the cited documents represent the results of a complete search, and it is anticipated that the Examiner in the normal course of examination, will make an independent search and will determine the best prior art consistent with 37 C.F.R. §1.104(a), and in the course of such search will review for relevance every document cited on the attached form even if not initialed.

Early and favorable consideration is earnestly solicited.

Respectfully submitted, Naor WAINER et al.

Paul Fenster,

Registration No. 33,877

aul Fenster

March 23, 2004

William H. Dippert, Esq. Reed Smith LLP 599 Lexington Avenue, 29th Floor New York, NY 10022-7650

Tel.: (212) 521-5400

•					ATTY DOCKET NO. 037/03962		SERIAL NO. US Div'l of 10/465,075				
	INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)					Naor WAINER et al.					
1						FILING			GROUP		
				U.S	Herewith To be assigned 3. PATENT DOCUMENTS						
*EXAMINER	_					CLASS	SUBCLASS	FILING DATE			
INITIAL								SUBCLASS	IF APPROPE	RIATE	
	1	4,210,805		1 Jul '80	KOBAYASHI, T. et al.						
	2	4,755,676		5 Jul '88	GAALEMA, S. et al.						
	3	5,677,539		14 Oct '97	APOTOVSKY, B. et al.						
	4	5,777,338		7 Jul '98	HE, Z.						
	5	5,821,539		13 Oct '98	MATZ, R. et al.						
	6	6,034,373		7 Mar '00	SHAHAR, A. et al.						
•	7	6,169,287		2 Jan '01	WARBURTON, W. K.						
-	8	6,583,420		June 2003	NELSON, et al.		:			:	
	9	6,333,504		Dece 2001	LINGR	EN, et al.					
-	10	2002/0079456		June 2002	LINGREN, et al.						
_	11	5,500,534		March 1996	ROBINSON, et al.						
	!			FORE	IGN PATE	NT DOCUMENTS		J			
		DOCUMENT NUMBER		DATE	COUNTRY		CLASS	SUBCLASS		LATION	
	12	CH 471 392		15 Apr '69	SWITZERLAND				YES	NO	
	13	DE 196 16 545		30 Oct '97	GERM	ANY		-			
	14	EP 0 291 351		17 Nov '88	EUROF					-	
	15	EP 0 527 373		17 Feb '93	EUROF	PE		1			
	16	FR 2 705 791		2 Dec '94	FRANC						
		1		L	<u></u>				<u> </u>		
	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)										
		17	HE, Z. et al.; "Coplanar Grid Patterns and Their Effect on Energy Resolution of CdZnTe Detectors;" IEEE Nuclear Science Symposium and Medical Imaging Conference; Albuquerque, Mexico; 9-15 November 1997								
		18	NAOAKI, I.; JP 02-163691 A; 22 June 1990 & Patent Abstracts of Japan; Vol. 014; No. 422 (P-1104); 12 September 1990								

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DATE CONSIDERED

Form PTO-A820 (also form PTO-1449)

EXAMINER

P09C/REV03

Patent and Trademark Office * U.S. DEPARTMENT OF COMMERCE

2	INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)					ATTY DOCKET NO. 037/0396	SERIAL NO. US Div'l of 10/465,075				
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			DOCUMENT NUMBER	DATE	COUNTRY			SUBCLASS	TRANSLATION YES NO		
	19	GB 2 017 295 WO 98/23974		3 Oct '79	UNITE	D KINGDOM					
	20			4 Jun '98	PCT	PCT					
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						··					
		г	OTHER DOCUME	NTS (Includir	ng Author	, Title, Date, Pertine	nt Pages, Etc	c.)			
		21	NAOAKI, I.; JP 05-333157 A; 17 December 1993 & Patent Abstracts of Japan; Vol. 018; No. 162 (P-1712); 17 March 1994								
		22	NAOKI, S.; JP 59-132382; 30 July 1984 & Patent Abstracts of Japan; Vol. 008; No. 265 (P-318); 5 December 1984								
EXAMINER					DATE CONSIDERED						
*EXAMINE considered	R: Init	ial if re	ference considered, whether	er or not citation is	in conform	ance with MPEP 609; Dr	aw line through	citation if not in c	onformance	and not	

Form PTO-A820 (also form PTO-1449)

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